



2825

**TRANSMITTAL LETTER**  
**(General - Patent Pending)**

Docket No.  
**PHNL000627**

Application Of: **Verhaar et al.**

|                                 |                                  |                            |                               |
|---------------------------------|----------------------------------|----------------------------|-------------------------------|
| Serial No.<br><b>09/989,250</b> | Filing Date<br><b>11/20/2001</b> | Examiner<br><b>Luu, C.</b> | Group Art Unit<br><b>2825</b> |
|---------------------------------|----------------------------------|----------------------------|-------------------------------|

Title: **METHOD OF FORMING A SEMICONDUCTOR STRUCTURE**

**TO THE ASSISTANT COMMISSIONER FOR PATENTS:**

Transmitted herewith is: **Amendment in 5 pages**  
**2 Return Receipt Postcards**

in the above identified application.

- ☒ No additional fee is required.
- ☐ A check in the amount of \_\_\_\_\_ is attached.
- ☒ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. \_\_\_\_\_ as described below. A duplicate copy of this sheet is enclosed.
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Dated: **February 5, 2003**

**John A. Merecki**  
**Reg. No. 35,812**  
**Hoffman, Warnick & D'Alessandro LLC**  
**Three E-Comm Square**  
**Albany, New York 12207**  
**(518) 449-0044**

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| I certify that this document and fee is being deposited on 2/5/2003 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231. |  |
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| <b>Dorothea Rubbone</b>  |  |
| Typed or Printed Name of Person Mailing Correspondence   |  |

CC:



DOCKET NO. PHNL000627

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Verhaar et al. )  
 )  
Application No.: 09/989,250 )  
 )  
Filed: 11/20/2001 )  
 )  
For: METHOD OF FORMING A )  
SEMICONDUCTOR STRUCTURE )

Examiner: Luu, C.  
Art Unit: 2825

*JH/gmdt B*

Box Non-Fee Amendment  
Commissioner for Patents  
Washington D.C. 20231

*2/14/03*

*RLBm*

AMENDMENT

Sir:

In response to the Office Action of November 6, 2002, Applicants respectfully request that the above-identified application be reconsidered in view of the amendments and remarks that follow, and that the application be passed to issue.

In the Specification:

On page 1, prior to first paragraph, please add the heading:

*B'*

FIELD OF THE INVENTION

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